



ATTORNEY'S DOCKET NO: S1022.80704US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Didier DUTARTRE and Patrick JERIER  
Serial No: 09/902,497  
Filed: July 10, 2001  
For: METHOD OF EPITAXY ON A SILICON SUBSTRATE COMPRISING  
AREAS HEAVILY DOPED WITH ARSENIC

Examiner: Matthew A. Anderson  
Art Unit: 1765

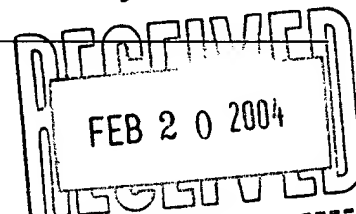
Confirmation No.: 7314

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first- class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 9, 2004.

*Eileen MacKenzie*  
Eileen MacKenzie

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450



Sir:

**PETITION FOR THREE MONTH EXTENSION OF TIME**

A three (3) month extension of time, to and including February 8, 2004, is requested for response to the Patent Office Communication of August 8, 2003. Since February 8, 2004 fell on a Saturday, this response is considered timely filed.

The extension fee of \$950.00 as set forth in 37 C.F.R. §1.17(a) is enclosed herewith. If the amount is insufficient, the balance may be charged to Deposit Account No. 23/2825.

Respectfully submitted,

Didier DUTARTRE and Patrick  
JERIER

02/18/2004 MAHMED1 00000035 09902497

01 FC:1253

950.00 DP

By: *James H. Morris*  
James H. Morris  
Reg. No.: 34,681  
WOLF, GREENFIELD & SACKS, P.C.  
600 Atlantic Avenue  
Boston, Massachusetts 02210  
Tel. (617) 720-3500

Attorney Docket No.: S1022.80704US00